

# *Certificate of Achievement*

*This certificate is presented to*

*A. Miyawaki, Y. Hayashi, M. Tanemura*

*in recognition of outstanding accomplishments  
as POSTER PRESENTER in the Nanoscience and Nanotechnology International  
Conference 2008 (NANO-SciTech 2008) on 18th -21st Nov 2008 in UiTM, Shah  
Alam, Selangor, Malaysia*

*LOW-TEMPERATURE FABRICATION OF GE  
NANOSTRUCTURES BY ION IRRADIATION  
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